

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: Not yet assigned

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Filed: November 25, 2003

In re Application of: WERNER, et al

For: "A SEMICONDUCTOR STRUCTURE FOR USE IN THE NEAR INFRARED REGION AND A METHOD OF MANUFACTURING THIS SEMICONDUCTOR STRUCTURE"

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10/723285



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Tamara Charland

TRANSMITTAL LETTER

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



Sir:

Enclosed for filing please find the patent application for an invention entitled, "A

SEMICONDUCTOR STRUCTURE FOR USE IN THE NEAR INFRARED REGION

AND A METHOD OF MANUFACTURING THIS SEMICONDUCTOR

STRUCTURE", filed on behalf of Max-Planck-Gesellschaft zur Forderung der Wissenschaften

e. V., a small entity, assignee from inventors Peter Werner, a citizen of Germany, Viatcheslav

Egorov, a citizen of Russia, Vadim Talalaev, a citizen of Russia, George Cirlin, a citizen of

Russia and Nikolai Zakharov a citizen of Russia, including 17 pages of specification, 4 pages of

claims, 1 page of abstract, and 10 sheets of drawing figures.